

## UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT Application of

Group Art Unit: Upk

Lu

Application No. 09/838,316

Examiner: Unassigned Sak cham

Filed: April 20, 2001

Att. Docket No.: 95-153

METHOD FOR FABRICATING SILICON-ON-INSULATOR MATERIA

January 8, 2003

## REQUEST FOR CORRECTION OF INVENTORSHIP UNDER RUL

Hon. Asst. Commissioner of Patents and Trademarks Washington, D.C. 20231

Sir:

Please add the following two co-inventors to the above-identified application: Yan Luo Hongyu Zhou.

Attached is a petition to add the two new co-inventors, in which each coinventor declares that the error occurred without deceptive intent. Also attached is a Declaration and Power of attorney signed by each inventor.

Enclosed is the required processing fee set forth in § 1.17(i). Please charge any deficiencies or credit any overpayment to our deposit account No. 50-0687, under Order No. 95-153.

> Respectfully submitted, Manelli Denison & Selter PLLC

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